

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

ATTY.'S DOCKET: ZALEVSKY4

In re Application of:

Seev ZALEVSKY et al

Appln. No.: 10/565,623

Filed: March 9, 2001

For: METHOD FOR PRODUCTION OF  
MICRO-OPTICS STRUCTURES

Confirmation No. 2605

Washington, D.C.

October 23, 2007

STATEMENT UNDER 37 CFR 1.497(d) (1)

Honorable Commissioner for Patents  
U.S. Patent and Trademark Office  
2011 South Clark Place  
Customer Window, Mail Stop Petitions  
Crystal Plaza Two, Lobby, Room 1803  
Arlington, VA 22202

Sir:

I, the undersigned Yuval Kapellner, hereby state  
that the error in inventership by which my name was omitted in  
the international application of which the above-identified  
application is the national stage, occurred without deceptive  
intention on my part.

24.10.2007  
Date

Yuval Kapellner